



Bib Data Sheet



## UNITED STATES DEPARTMENT OF COMMERCE Patent and Trademark Office

Address: COMMISSIONER OF PATENTS AND TRADEMARKS Washington, D.C. 20231

<b>SERIAL NUMB</b> 09/478,812	ER	<b>FILING DATE</b> 01/07/2000 <b>RULE</b> _	<b>CLASS</b> 438		GROUP ART UNIT 2825		ATTORNEY DOCKET NO. SON-1718			
APPLICANTS								***************************************		
Yukiyasu Si Masahiro Fi Michio Man Akihiko Asa Masumitsu Takenobu U Makoto Tak	ujino, o, Kai ino, K Ino, K Jrazoi katoku	o, Kanagawa, JAPAN; Kanagawa, JAPAN; nagawa, JAPAN; anagawa, JAPAN; (anagawa, JAPAN; no, Kanagawa, JAPAN; I, Kanagawa, JAPAN;								
** FOREIGN APPLICATIONS ************************************										
IF REQUIRED, FOREIGN FILING LICENSE GRANTED  ** 03/15/2000 -										
Foreign Priority claimed  35 USC 119 (a-d) conditions			STATE OR COUNTRY JAPAN	SHEETS DRAWING 31		<b>TO</b> 1 <b>CLA</b>		INDEPENDENT CLAIMS 31		
ADDRESS								***************************************		
Ronald P Kanane Rader Fishman & The Lion Building 1233 20th Street I Washington ,DC	Grau	er ·		_						
TITLE Process for producing thin film semiconductor device and laser irradiation apparatus										
						All Fees  1.16 Fees ( Filing )				
RECEIVED	FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT					1.17 Fees ( Processing Ext. of time )				
3976	No for following:					1.18 Fees (Issue) Other				
						☐ Credit				